

ABSTRACT

Disclosed is a method for forming a metal back-attached phosphor screen, the method comprising the steps of: forming a phosphor layer (10) on an inner surface of a face plate (8); disposing
5 a transfer film (1) in which at least a release agent layer (3), a smooth resin film (4) and an adhesive agent layer (5) are formed on a base film (2) onto the phosphor layer (10), pressing the transfer film (1) while applying heat by a transfer roller (7) to bond the
10 transfer film (1), to thereby transfer the resin film; forming a metal film on the transferred resin film; and heating the face plate in which the metal film is formed.